



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Ken YOSHIZAWA

Group Art Unit: 1722

Application No.: 10/565,108

Examiner: F. HITESHEW

Filed: January 19, 2006

Docket No.: 126623

For: A METHOD FOR PRODUCING A SILICON WAFER AND A SILICON WAFER

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the July 5, 2007 Office Action, please consider the following:

Amendments to the Specification;

Amendments to the Claims as reflected in the listing of claims;

Remarks.